

Notice of References Cited	Application/Control No. 10/689,623	Applicant(s)/Patent Under Reexamination CHO ET AL.	
	Examiner Kenneth A. Parker	Art Unit 2871	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,359,206	10-1994	Yamamoto et al.	257/59
	B	US-5,929,958	07-1999	Ohta et al.	349/141
	C	US-6,870,559	03-2005	Kanno, Satoru	347/250
	D	US-6,633,361	10-2003	Fujita, Akira	349/152
	E	US-6,226,059	05-2001	Yamamoto et al.	349/42
	F	US-5,825,439	10-1998	Noriyama, Hidetaka	349/54
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 05265021 A	10-1993	Japan	SAKAGUCHI et al.	G02F 01/1345
	O	JP 08082805 A	03-1996	Japan	NISHIKAWA, RYUJI	G02F 01/1345
	P	JP 07072508 A	03-1995	Japan	KONYA, NAOHIRO	G02F 01/136
	Q	JP 08201833 A	08-1996	Japan	SAKAISHI et al.	G02F 01/1345
	R	JP 06146225 A	05-1994	Japan	YOSHIDA, HIROSHI	E01F 07/04
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.